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Electronic Patent Application Submission
USPTO Use Only

EFS ID: 63000

Application ID: 10811624



Title of Invention:

METHOD OF SELF-ALIGNING AN
OXIDE APERTURE WITH AN
ANNULAR INTRA-CAVITY
CONTACT IN A LONG
WAVELENGTH VCSEL

First Named Inventor: Leo CHIROVSKY

Domestic/Foreign Application: Domestic Application

Filing Date: 2004-03-29

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Submission Type: Information Disclosure
Statement

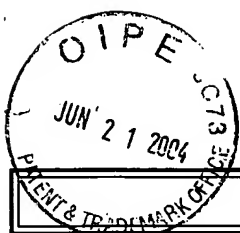
Filing Type:

Confirmation number: 2731

Attorney Docket Number: 0013P00903US2


Total Fees Authorized:

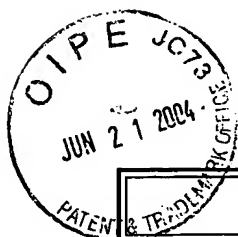
Digital Certificate Holder: cn=David Josephs,ou=Registered Attorneys,ou=Patent and Trademark
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**TRANSMITTAL**

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	METHOD OF SELF-ALIGNING AN OXIDE APERTURE WITH AN ANNULAR INTRA-CAVITY CONTACT IN A LONG WAVELENGTH VCSEL	
Application Number: 10/811624 		
Date: 2004-03-29		
First Named Applicant: Mr. Leo M. CHIROVSKY		
Confirmation Number: 2731		
Attorney Docket Number: O013P00903US2		
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Submitted by:	Elec. Sign.	Sign. Capacity
Mr. Stephen J. Holmes Registered Number: 34621	/stephen.j.holmes/	Attorney
Documents being submitted	Files	
us-ids	P00903US2-usidst.xml	
	us-ids.dtd	
	us-ids.xsl	
Comments		



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

**METHOD OF SELF-ALIGNING AN OXIDE APERTURE
WITH AN ANNULAR INTRA-CAVITY CONTACT IN A LONG
WAVELENGTH VCSEL**

Application Number: 10/811624



Confirmation Number: 2731

First Named Applicant: Leo CHIROVSKY

Attorney Docket Number: O013P00903US2

Art Unit: 2812

Search string: (5985683 or 5991326 or 6075804 or 6169756
or 6411638 or 6618414 or 20020090016 or
20020101894 or 20020131462 or 20020150135
or 20030031221 or 20030185267 or
20040058467).pn.

US Patent Documents

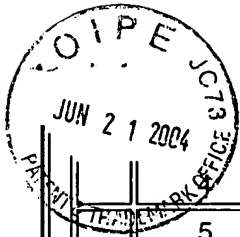
Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5985683	1999-11-16	Jewell		438	22
	2	5991326	1999-11-23	Yuen et al.		372	96
	3	6075804	2000-06-13	Deppe et al.		372	96
	4	6169756	2001-01-02	Chirovsky et al.	B1	372	46
	5	6411638	2002-06-25	Johnson et al.	B1	372	46
	6	6618414	2003-09-09	Wasserbauer et al.	B1	372	45

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20020090016	2002-07-11	Coldren et al.	A1	372	96
	2	20020101894	2002-08-01	Coldren et al.	A1	372	43
	3	20020131462	2002-09-19	Lin et al.	A1	372	43



		20020150135	2002-10-17	Naone et al.	A1	372	45
	5	20030031221	2003-02-13	Wang	A1	372	45
	6	20030185267	2003-10-02	Hwang et al.	A1	372	96
	7	20040058467	2004-03-25	Chirovsky et al.	A1	438	32

Signature

Examiner Name	Date